

How well do we know

Wafer geometry?

Systematic distortions.

Theory:

- All faces measured to  $\approx 1 \mu\text{m}$  in lab
- With redundancy: 4 pts / wafer
- Cross checks: wafer size (known  $\approx 1\mu\text{m}$ )
- Thermal effects negligible (water cooling)
- Some degrees of freedom frozen mainly  $\approx$  wafer position in face.
- Final geometry determined by align<sup>+</sup> procedure at 2 peak. TPC not used
- Monitored at high energy with laser and overlaps (run quality plots)

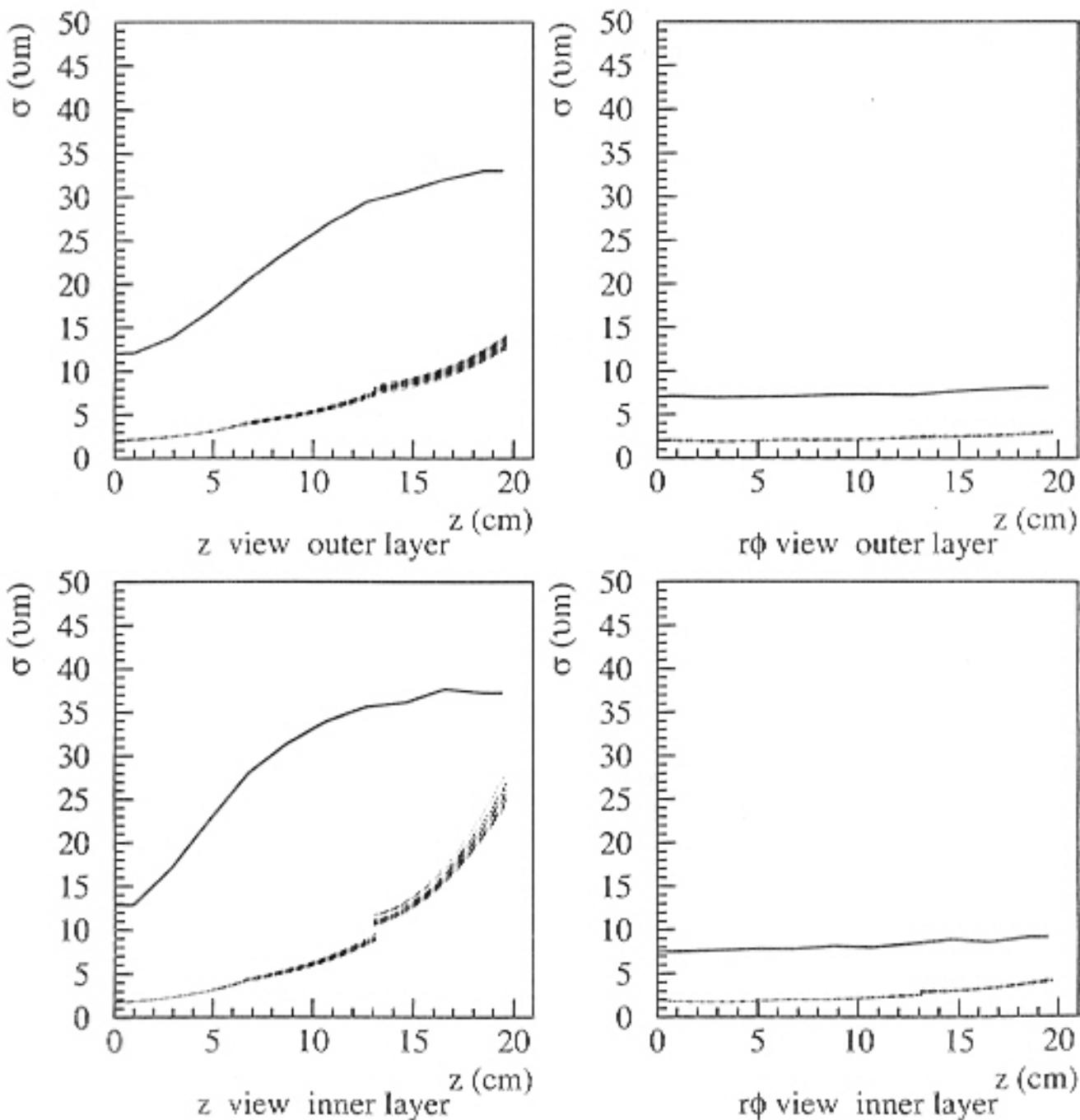


Figure 6: The dotted lines show the alignment errors in both views for all faces as a function of  $z$ , obtained from  $10 \text{ pb}^{-1}$  of 161 GeV data. The solid lines show the intrinsic hit error.

How far can we trust the alignment?

- Thermal effects negligible because of  
...wafer monitoring  
monitored with laser
- Visible movements seen during fill  
I switched on / off
- Humidity effects (change R)  
monitored with overlaps
- Keep in mind that wafers do not  
change size. Movements are due to  
differential expansion between support  
and silicon.



Verify with data.

### Overlaps

$$\delta r\varphi \approx 0.5 \delta R$$



In 1996, humidity in Kevlar  $R$  caused bowing of faces  $\approx 100 \mu\text{m}$   
Immediately seen, corrected run by run.

---

Dimuons Voter alone

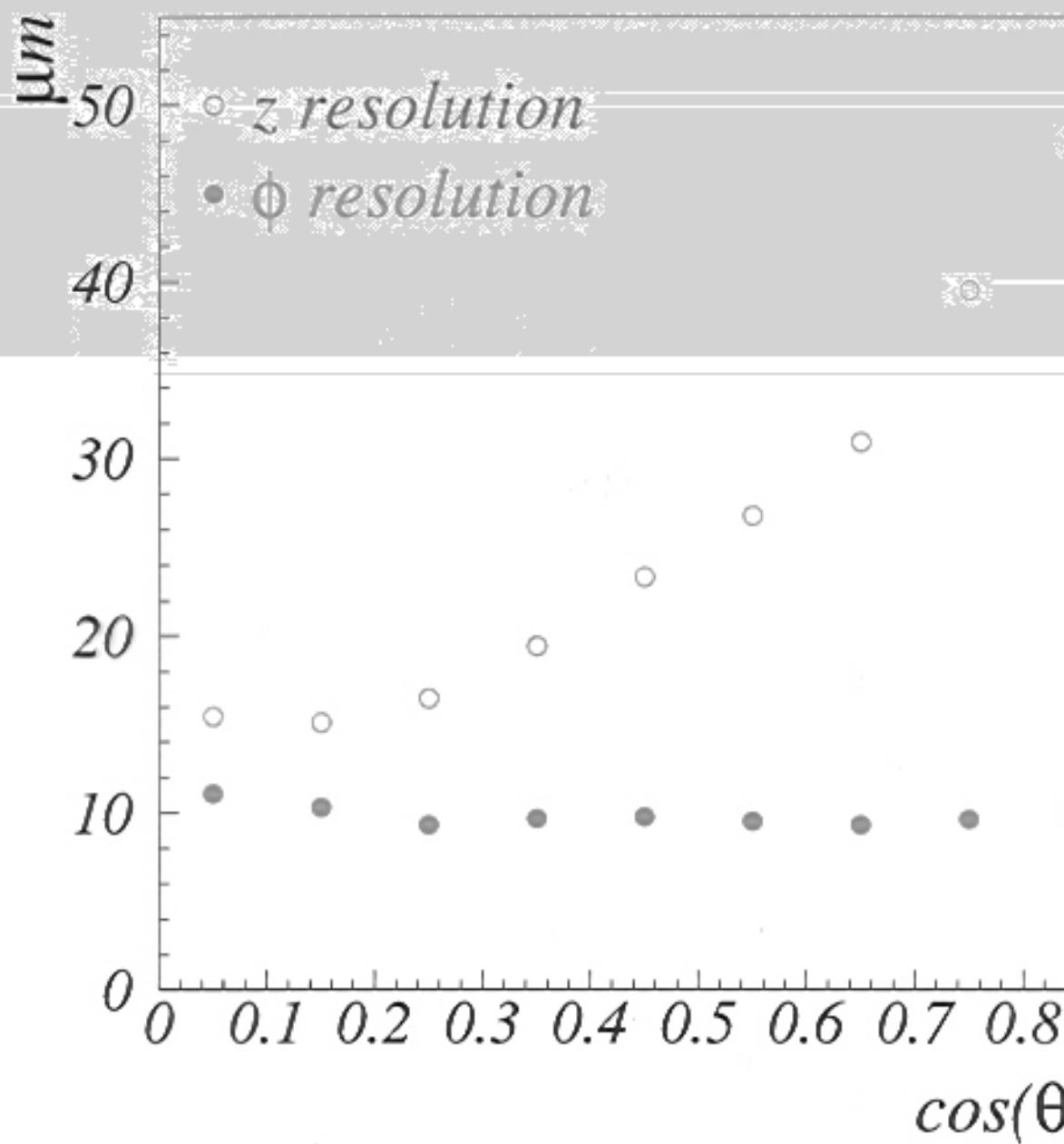
4 hits, 2 tracks

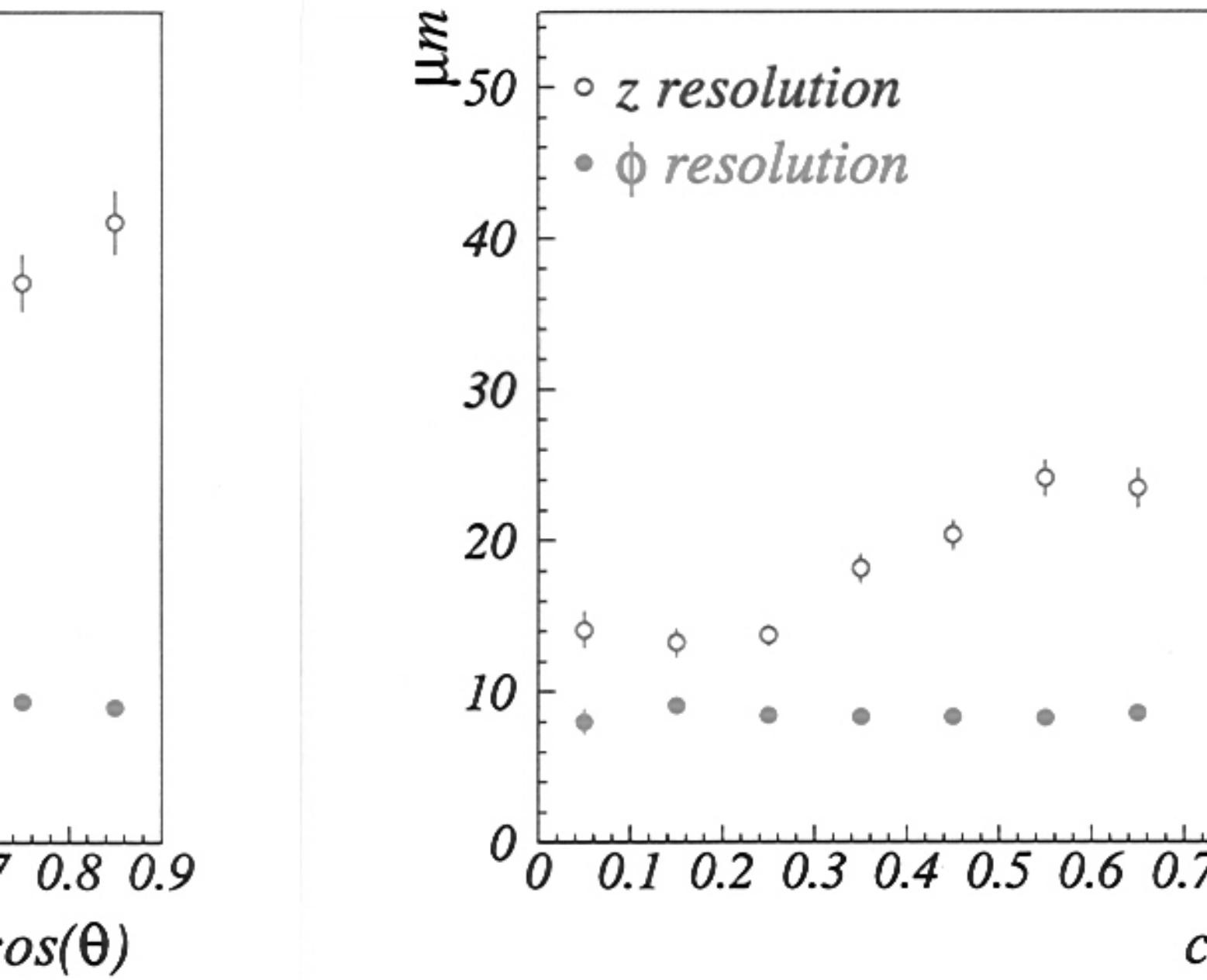
$$\Delta z_0 \Rightarrow \nabla z$$

$$\sum d_0 \Rightarrow \nabla r\varphi$$



## *Resolution vs. $\cos(\theta)$*



*Resolution vs.  $\cos(\theta)$* 

## Conclusion

Voder geometry is probably accurate  
to  $\approx 10 \mu\text{m}$ .

Deviations by  $100 \mu\text{m}$  or more  
are extremely unlikely

Note:  $100 \mu\text{m} / 10 \text{ cm} = 10^{-3} \text{ rad.}$